



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

May 4, 2007

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

RE: Applicant: Daniel et al.
 Serial No.: 10/721,819
 Filing Date: 11/24/2003
 Art Unit: 2143
 Attorney Docket No.: RSW920030279US1
 Title: Tool for Displaying JMX Monitoring Information

Dear Sir or Madam:

Transmitted herewith are the following:

1. Information Disclosure Statement;
2. Java Management Extensions Instrumentation and Agent Specification, v1.2

Each item of information contained in the information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement.

Respectfully Submitted,

Rudolf O. Siegesmund
Rudolf O. Siegesmund
Registration No. 37,720
Suite 2650
2100 Ross Avenue
Dallas, Texas 75201
(214) 231-4660
FAX (214) 461-4053
Attorney for Applicant



Date of Deposit: 5/4/07

I hereby certify that this paper and fee are being deposited with the United States Postal Service as first class mail under 37 CFR 1.10 on the date indicated above and is addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313

Patricia Milfeld
Patricia Milfeld



In Place of FORM PTO-1449 (Modified)

**LIST OF PATENTS AND PUBLICATIONS FOR
APPLICANT'S INFORMATION DISCLOSURE
STATEMENT**

Serial No. 10/721,819
Applicant: Daniel et al.
Filing Date: 11/24/2003
Group: 2143
Atty. Docket No. RSW920030279US1

Reference Designation				<u>U. S. PATENT DOCUMENTS</u>			Filing Date if
Examiner Initial	Document Number	Date	Name	Class	Subclass	Appropriate	
	AA 2005/0125719	06/2005	Daniel et al.	715	513		

<u>FOREIGN PATENT DOCUMENTS</u>						Translation Yes No
Examiner Initial	Document Number	Date	Country	Class	Subclass	
AA						

OTHER ART (Including Author, Title,
Date, Pertinent Pages, Etc.)

Examiner
Initial

AA SUN MICROSYSTEMS, "Java Management Extensions Instrumentation and Agent Specification," Sun Microsystems, Santa Clara, CA, October 2002, Vol.1.2

Examiner: _____ Date Considered: _____

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.